Docket No. SH-0067PCTUS

IAP12 Rec'd PCT/PTO 1 8 SEP 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Makoto YOSHIDA, et al.

Serial No.:

Not Yet Assigned

Group Art Unit:

Not Yet Assigned

Filing Date:

Concurrently Herewith

Examiner:

Not Yet Assigned

For:

SINTERING METHOD AND SINTERING APPARATUS OF POROUS GLASS

BASE MATERIAL

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicants duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents listed on the attached form PTO-1449, which are cited in the International Search Report (PCT Form PCT/ISA/210) to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner. Further, in compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, English-language Abstracts are attached to the references, and the relevance of one of the references is described on page 2 of the application.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Date:

MCGINN INTELLECTUAL PROPERTY

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Respectfully submitted,

Sean M. McGinn, Esq. Registration No.: 34,386

Docket Number (Optional) SH-0067PCTUS Applicant(s) INFORMATION DISCLOSURE CITATION Makoto YOSHIDA, et al. (Use several sheets if necessary) Group Art Unit Filing Date Concurrently Herewith Not Yet Assigned U.S. PATENT DOCUMENTS FILING DATE CLASS SUBCLASS NAME *EXAMINER DATE REF DOCUMENT NUMBER IF APPROPRIATE INITIAL U.S. PATENT APPLICATION PUBLICATIONS FILING DATE SUBCLASS CLASS EXAMINER DATE NAME DOCUMENT NUMBER REF IF APPROPRIATE INITIAL FOREIGN PATENT DOCUMENTS Translation CLASS SUBCLASS COUNTRY DATE DOCUMENT NUMBER REF YES NO ABS 08/08/2000 Japan 2000-219532 05/09/2000 Japan 2000-128563 ABS 09/26/2000 Japan 2000-264649 APS 09/19/2000 Japan 2000-256020 (Including Author, Title, Date, Pertinent Pages, Etc.) OTHER DOCUMENTS DATE CONSIDERED **EXAMINER** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.